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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:

Hirofumi KUBOTA

Application No.: 10/797,573

Filed: March 11, 2004

For: ORGANIC ELECTROLUMINESCENCE )  
DISPLAY PANEL AND FABRICATION )  
METHOD THEREOF )

Confirmation No.: 4829

Group Art Unit: 2879

Examiner: Kevin J. Quarterman

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**INFORMATION DISCLOSURE STATEMENT UNDER C.F.R. § 1.97(c)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(c), Applicant brings to the attention of the Examiner the documents listed on the attached PTO-1449. This Information Disclosure Statement is being filed after the events recited in § 1.97(b) but, to the undersigned's knowledge, before the mailing date of a Final Action, a Notice of Allowance, or another action that closes prosecution in the above-referenced application. Under the provisions of 37 C.F.R. § 1.97(c), this Information Disclosure Statement is accompanied by a fee of \$180.00, as specified by § 1.17(p).

A European Search Report dated March 29, 2006 that issued in a counterpart European patent application and having documents cited therein is attached for the Examiner's consideration. While the European Search Report cites to JP 2003-282241, this document is not listed on the attached PTO Form 1449 because it was cited in the Office Action dated February

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7, 2006 in this application. The remaining cited documents are listed on the attached PTO Form 1449 and the non-U.S. documents are also attached hereto. Two of the cited documents listed on the attached PTO Form 1449 are in a language other than English. The relevance of these documents can be understood from the attached English-language Abstract and also from their citation in the attached European Search Report.

Applicant respectfully requests that the Examiner consider the listed documents and evidence that consideration by making appropriate notations on the attached form.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed documents are material or constitute "Prior Art". If it should be determined that any of the listed documents do not constitute "Prior Art" under the United States law, Applicant reserves the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over any of the listed documents, should the document be applied against the claims of the present application.

**EXCEPT** for issue fees payable under 37 C.F.R. § 1.18, the Commissioner is hereby authorized by this paper to charge any additional fees during the entire pendency of this application including fees due under 37 C.F.R. § 1.16 and 1.17 which may be required, including

any required extension of time fees, or credit any overpayment to Deposit Account No. 50-0573.

This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENIONS OF TIME** in accordance with 37 C.F.R. § 1.13(a)(3).

Respectfully submitted,

**DRINKER, BIDDLE & REATH LLP**

Dated: April 14, 2006

By:



Paul A. Fournier

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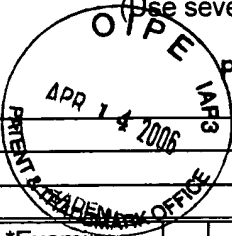
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(Use several sheets if necessary)

PTO Form 1449

Group Art Unit: 2879
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		“Thermo-Catalytic Deposition of Silicon Nitride – A New Method For Excellent Silicon Surface Passivation”, by Jens D. Moschner et al.; pgs. 174 – 177; May 19, 2002.

Date Considered

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